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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshio SAKURAI et al.

Application No.: 10/564,393

Filed: May 8, 2006

Docket No.: 126617

For: LOW DIELECTRIC CONSTANT FILMS AND MANUFACTURING METHOD
THEREOF, AS WELL AS ELECTRONIC PARTS USING THE SAME

INFORMATION DISCLOSURE STATEMENT

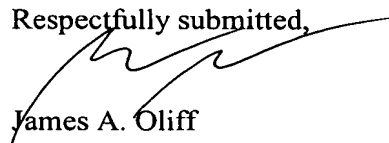
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See Reference 1.
- ☒ 3. A translation for References 1 - 4 is enclosed.

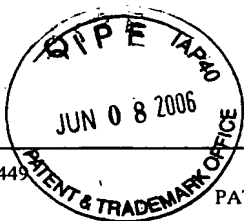
Respectfully submitted,


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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Sheet 1 of 1Form PTO-1449
(REV. 1/06)US Dept. of Commerce
PATENT & TRADEMARK OFFICEATTY DOCKET NO.
126617APPLICATION NO.
10/564,393

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANTS
Toshio SAKURAI et al.FILING DATE
May 8, 2006

GROUP

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Name

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation

OTHER DOCUMENTS

Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)
	1	Hiroyuki Tomimoto et al., "The 50 th Spring Meeting", The Japanese Society of Applied Physics and Related Societies Extended Abstracts, No. 2, 29a-ZG-1, p. 913, 2003 (with English translation).
	2	Hiroyuki Tomimoto et al., "The 51 st Spring Meeting", The Japanese Society of Applied Physics and Related Societies Extended Abstracts, No. 2, 28p-P3-19, p. 920, 2004 (with English translation).
	3	Sachiko Ishikawa et al., "The 51 st Spring Meeting", The Japanese Society of Applied Physics and Related Societies Extended Abstract, No. 1 28p-F-2, p. 206, 2004 (with English translation).
	4	Hiroyuki Tominoto et al., "The 64 th Autumn Meeting", The Japanese Society of Applied Physics and Related Societies Extended Abstracts, No. 2, 1a-YB-3, p. 753, 2003 (with English translation).

EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: June 8, 2006